

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10045849	FILING DATE 11/07/2001	CLASS 204	SUBCLASS 192.12	GAU 1753	EXAMINER MCDONALD, R
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\*\*APPLICANTS: Park Young;

\*\*CONTINUING DATA VERIFIED:

THIS APPLICATION IS A CON OF 09/542,799 04/04/2000 ABN \*  
WHICH CLAIMS BENEFIT OF 60/144,602 07/19/1999

(\*)Data provided by applicant is not consistent with PTO records.

\*\* FOREIGN APPLICATIONS VERIFIED:

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☒ no

35 USC 119 conditions met ☐ yes ☒ no

Verified and Acknowledged Examiners's initials *me*

ATTORNEY DOCKET NO

YP-001.C1

TITLE : High throughput thin film deposition and substrate handling method and apparatus for optical disk processing

U.S. DEPT. OF COMM / PAT & TM-PTO-436L (Rev. 12-94) 94

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
ISSUE FEE		Sheets Drwg.	Figs. Drwg.
Amount Due	Date Paid	Print Fig.	
Primary Examiner		Application Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
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FILED WITH: ☐ DISK (CRF)

☐ CD-ROM

(Attached in pocket on right inside flap)